Electronic Supplementary Information (ESI) for

## Thickness-controllable coating of SiO2 on Co microspheres with

## tunable electromagnetic properties and enhanced oxidation

## resistance

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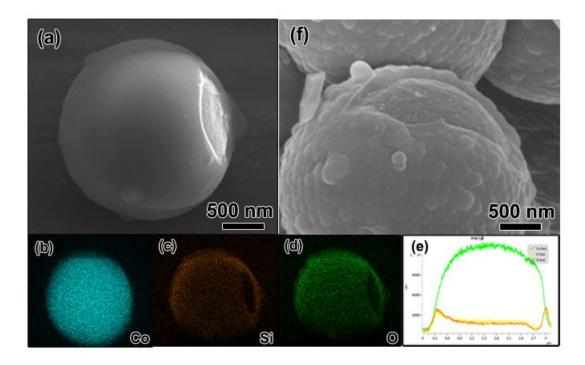
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**Fig. S1** (a) SEM images, (b-d) elemental maps of Co, Si and O, and (e) line scanning of a single broken Co@SiO<sub>2</sub> composite microsphere coated for three times. (f) SEM image of Co@SiO<sub>2</sub>

composite microsphere coated for five times.